

03/29/01

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March 30, 2001



**Box PATENT APPLICATION**  
Commissioner for Patents  
Washington, D.C. 20231

Re: New U.S. Patent Appln.  
Our Ref: 622/49809

Sir:

Transmitted herewith for filing is a Continuation Application of pending PCT Application No. PCT/CH99/00399 filed on August 30, 1999 of:

**Juergen WEICHART**entitled: **VACUUM TREATMENT CHAMBER AND METHOD FOR TREATING SURFACES**

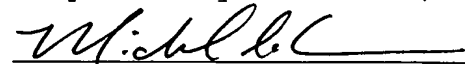
Enclosed are:

1. Specification, including 12 claims (pages 1-23, plus specification cover sheet).
2. 3 Sheets of X Formal      Informal drawings showing Figs. 1 - 7.
3. X Declaration and Power of Attorney (**unexecuted**).
4. Priority is being claimed under 35 U.S.C. §119 and 37 C.F.R. §1.55 based on Priority Document 1986/98, filed in Switzerland on September 30, 1998. A certified copy of the priority document was filed in PCT Application No. PCT/CH99/00399.
5. Benefit is hereby claimed under 35 U.S.C. §120 of pending PCT Application No. PCT/CH99/00399 filed on 30 August 1999.
6. X Information Disclosure Statement w/six (6) references.
7. The filing fee has been calculated as shown below:

Basic Fee				\$355/710 =	\$710.00
Total Claims	<u>12</u>	- 20 =	<u>0</u>	x \$09/18 =	\$
Independent Claims	<u>2</u>	- 3 =	<u>0</u>	x \$40/80 =	\$
Multiple Dependent Claim Presented				\$135/270 =	\$
Total Filing Fee					<u>\$710.00</u>

The filing fee is being deferred at this time.

Respectfully submitted,

  
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DDE:MIC:tvq